



Patent
CIT.PAU.01

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1753

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Scherer et.al.

Examiner: R.McDonald
Group Art Unit: 1753

Serial No.: 10/068,283

Filed: Feb. 5, 2002

For: Dry Etching and Mirror
Deposition Processes for Silicone
Elastomer

OK TO
ENTER
11/16/04

SECOND AMENDMENT AFTER FINAL

Hon. Commissioner of Patents and Trademarks
Washington DC 20231

Sir:

In reply to the Office Sept. 10, 2004, please consider the following
remarks and enter the following amendments.

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 this paper.

Remarks begin on page 8 of this paper.